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PATENT

Attorney Docket No.
033082 M 283

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of:) CONFIRMATION NO.: 2214

Shigeru NAKAJIMA, et al.)

U.S. Serial No.: 10/552,468) Group Art Unit: 2891

Filed: October 7, 2005) Examiner: Victor V. Yevsikov

For: FILM FORMING METHOD AND APPARATUS

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir :

A response to the Office Action mailed February 9, 2007 is due by March 9, 2007. The Action required restriction between the following:

Group I of claims 1-7, drawn to a film forming method; and

Group II of claim 8, drawn to an apparatus.

Applicants hereby elect Group I of claims 1-7, drawn to a film forming method, for examination in this application. Applicants advise that no change in the inventorship of the application will be required by the eventual cancellation of non-elected claims.

Applicants reserve the right to file divisional application(s) for the non-elected claims in due course. Also, Applicants remind the Examiner that new claims 9-13 were added to this application by the Preliminary Amendment filed in the United States Patent and Trademark Office on October 7, 2005.

It is submitted that this application now is in condition for examination on the merits and early action in that regard is solicited.

Respectfully submitted,
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Date : March 1, 2007